

03500.017597.



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
MASAKI MIZUTANI, et al.) Examiner: M. J. Song
Application No.: 10/670,301) Group Art Unit: 1722
Filed: September 26, 2003)
For: METHOD FOR GROWING)
SILICON FILM, METHOD FOR)
MANUFACTURING SOLAR)
CELL, SEMICONDUCTOR)
SUBSTRATE, AND SOLAR)
CELL) April 13, 2006

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action dated January 13, 2006, please amend the
above-identified application, as follows:

04/19/2006 SDENB01 00000006 10670301
01 FC:2203 180.00 DP
Void date: 04/19/2006 SDENB01
04/19/2006 SDENB01 00000006 10670301
01 FC:2203 -180.00 DP

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to:
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Damond E. Vadnais, Reg. No. 52,310
(Name of Attorney for Applicant)

Signature

April 13, 2006
Date of Signature